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### Title

Electric Power Sensing for Demand Response

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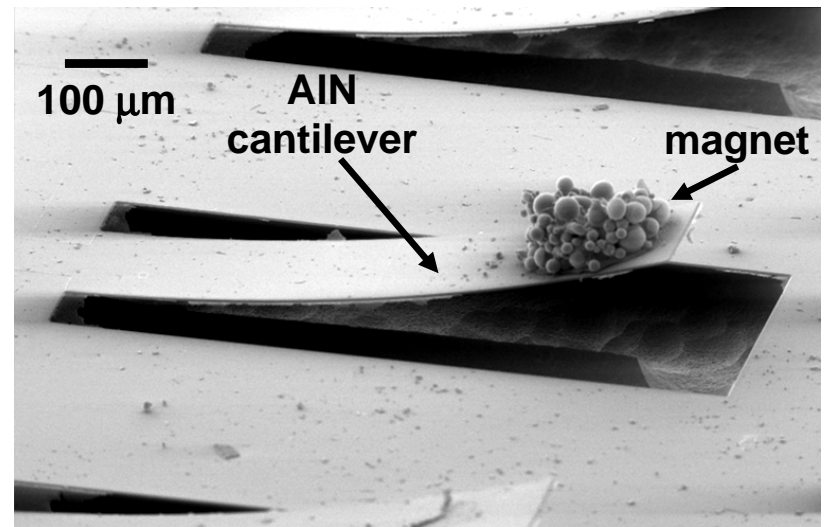
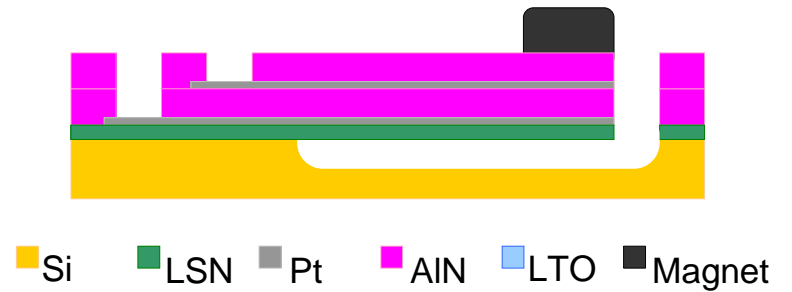
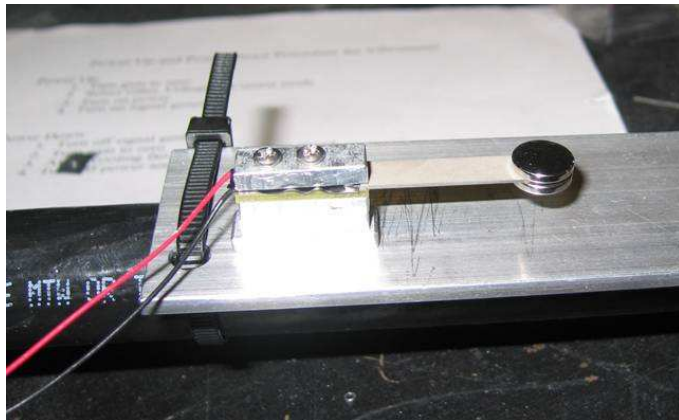
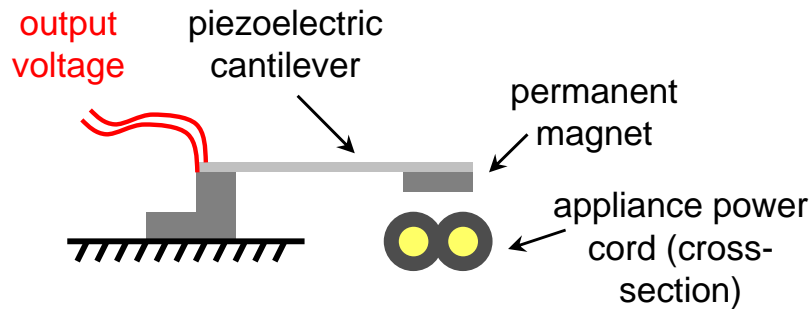
# Electric Power Sensing for Demand Response

*September 15, 2009*

*Eli S. Leland, Christopher T. Sherman, Peter Minor,  
Dr. Igor Paprotny, Prof. Paul K. Wright, Prof. Richard M. White*



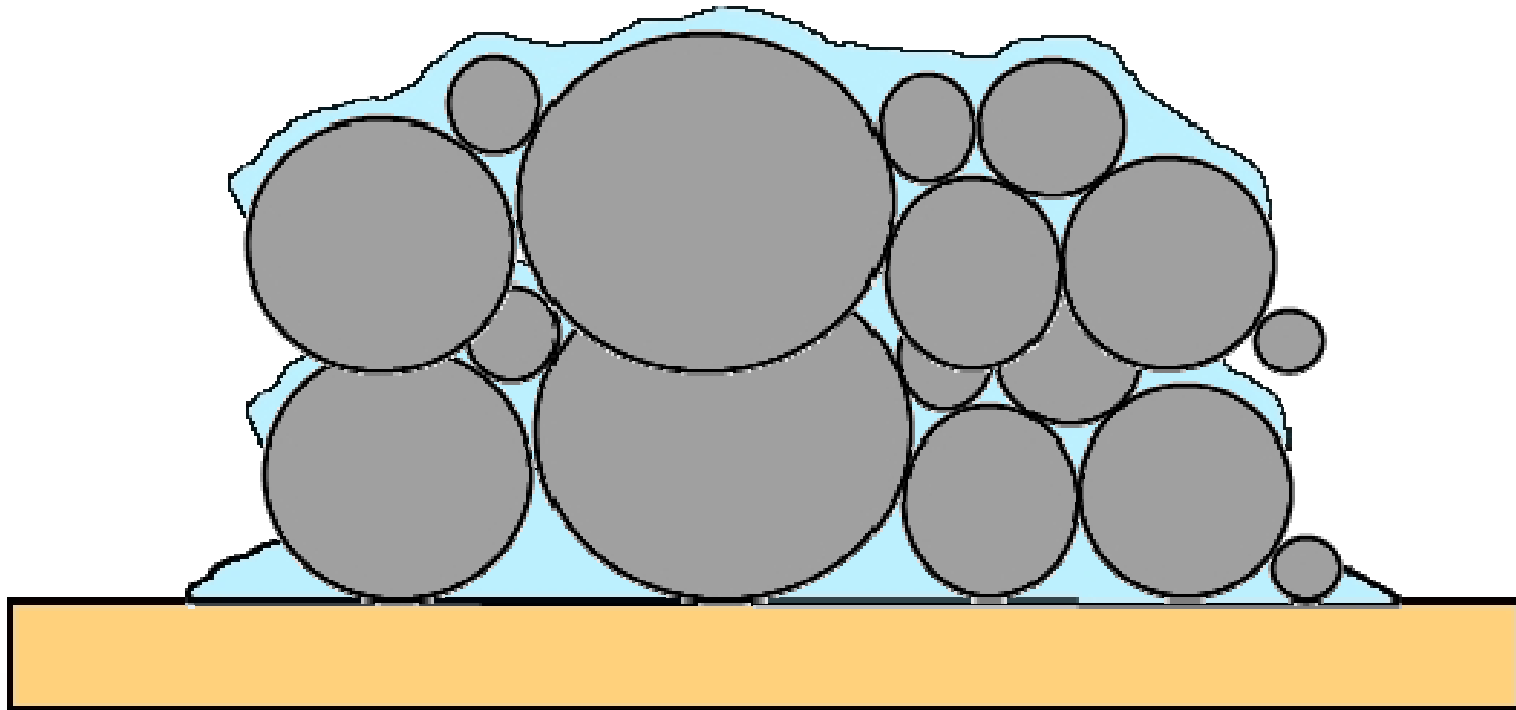
# Mesoscale to microscale...



# MEMS magnet development for current sensing

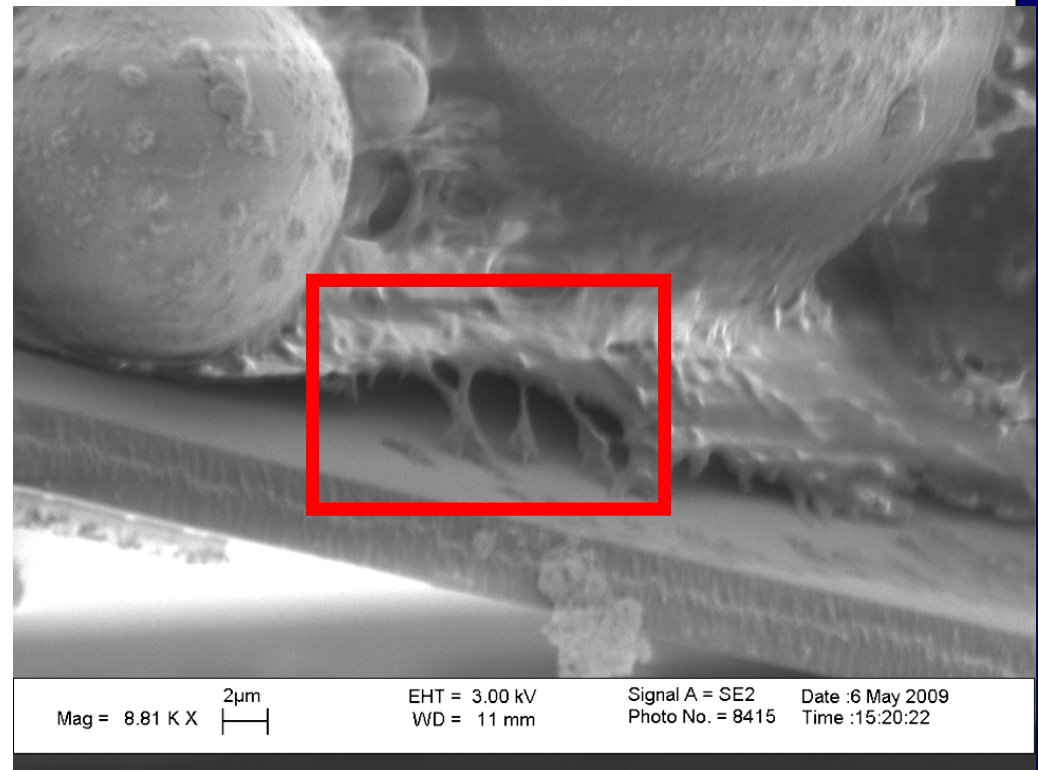
# Dispersed-powder method for magnet fabrication

Process can be repeated to improve aspect ratio



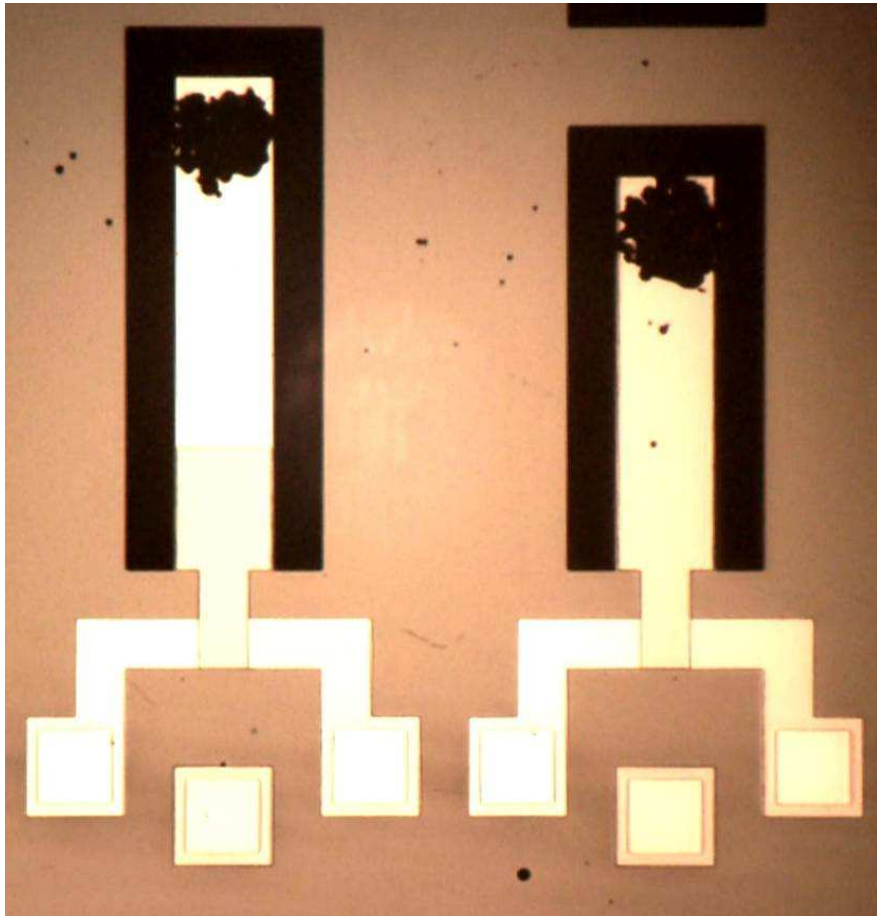
# Problems with PVDF

- PVDF initially chosen due to printer compatibility
- But evaporation of NMP solvent causes volume change
  - Possible delamination from substrate during curing

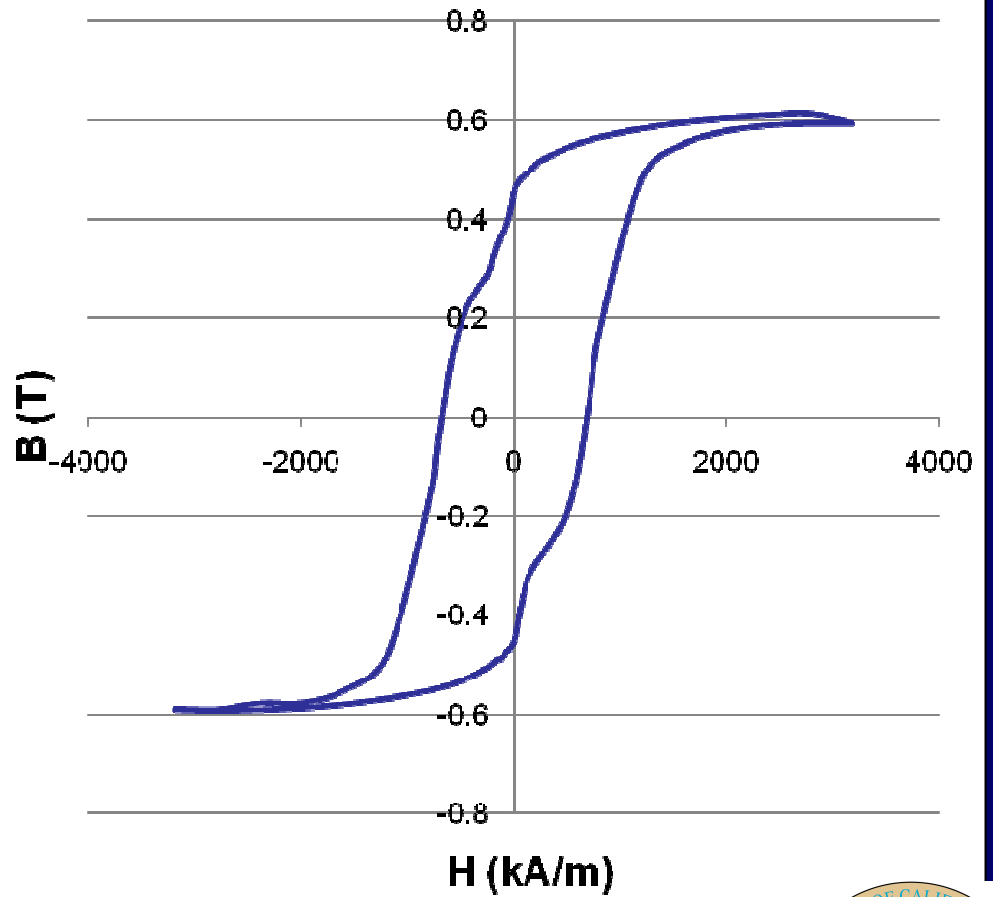


# Results with epoxy

## Magnets on Cantilevers

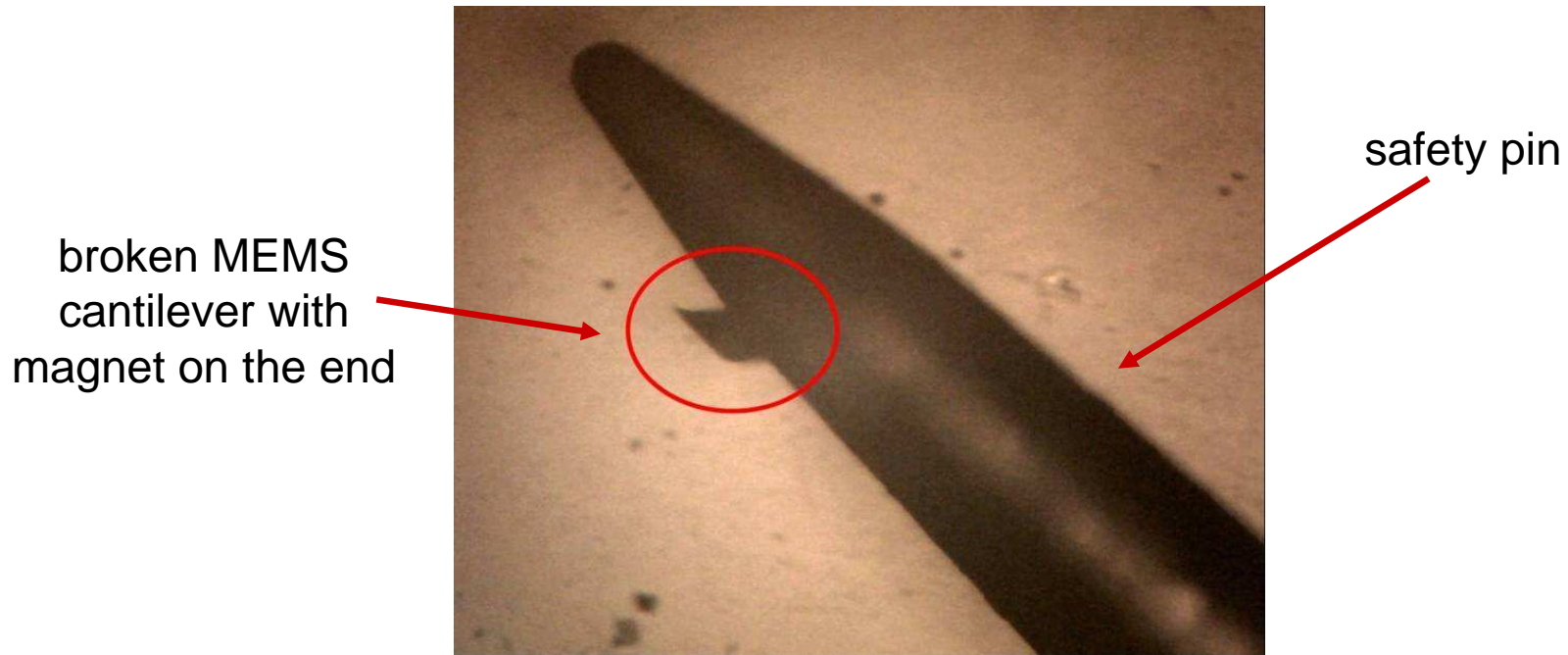


## Magnetic Performance





# Real-world magnet test



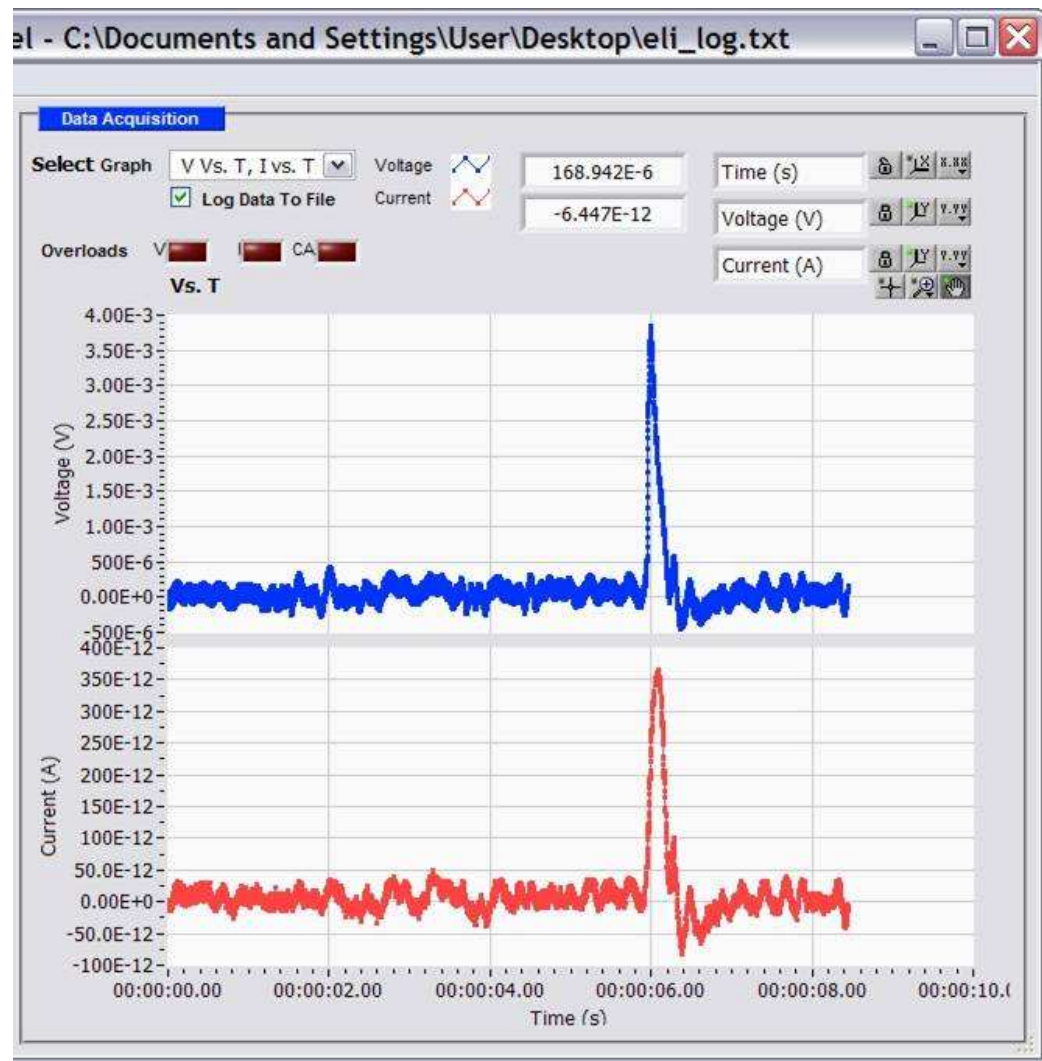
- Although magnetic testing indicated remanent magnetization, we wanted to make sure that translated into actual devices
- It sticks to a safety pin!



# MEMS integrated device testing

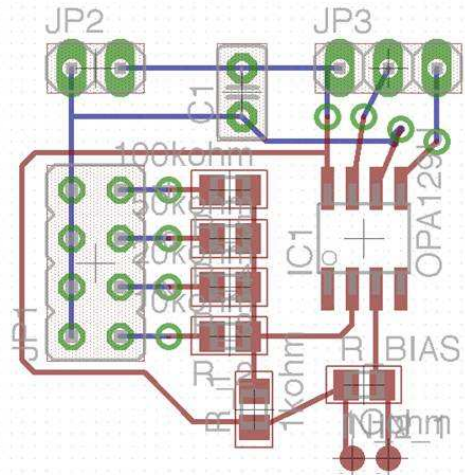
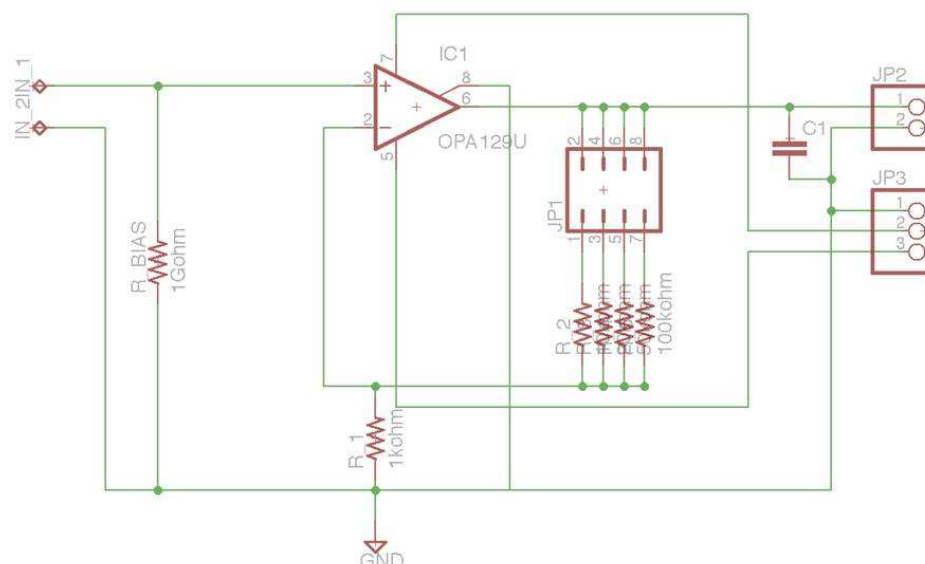
# "Hello, world"

- Mounted sample on probe station, probed two electrodes, "plucked" an AlN cantilever with a third probe tip
- Recorded ~4 mV signal using Gamry Reference 600 galvanostat/potentiostat
- In this experiment, a 10 MOhm resistor was placed in parallel with the MEMS cantilever (doesn't work otherwise)



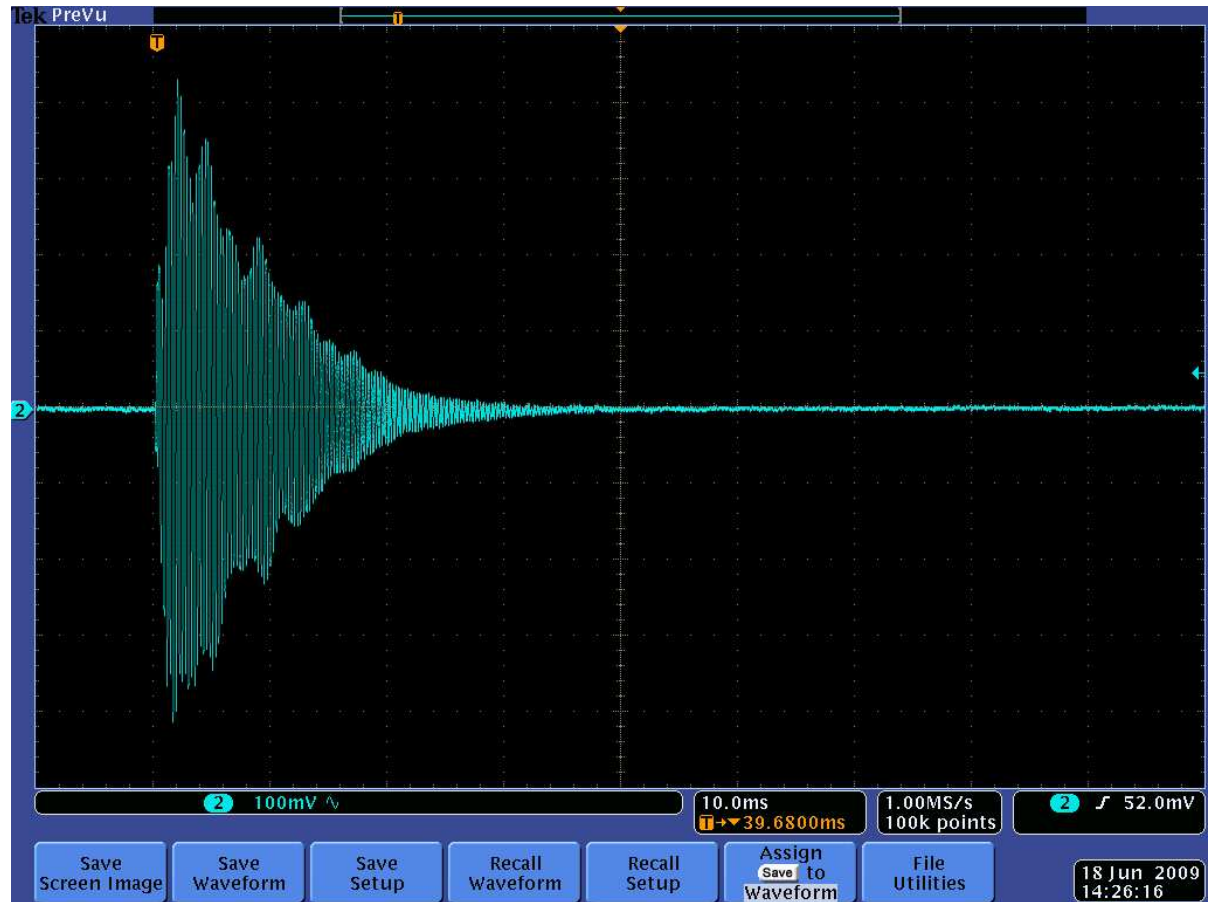
# Development of an op-amp circuit

- Designed a straightforward non-inverting op-amp circuit using a TI/Burr-Brown OPA129 and jumper-selectable gain
- This time a 1 GOhm bias resistor prevents the input from floating
- Modeled piezoelectric device as an AC current source in series with a similar-value capacitor (in Spice) and did the same in actual breadboard circuit testing



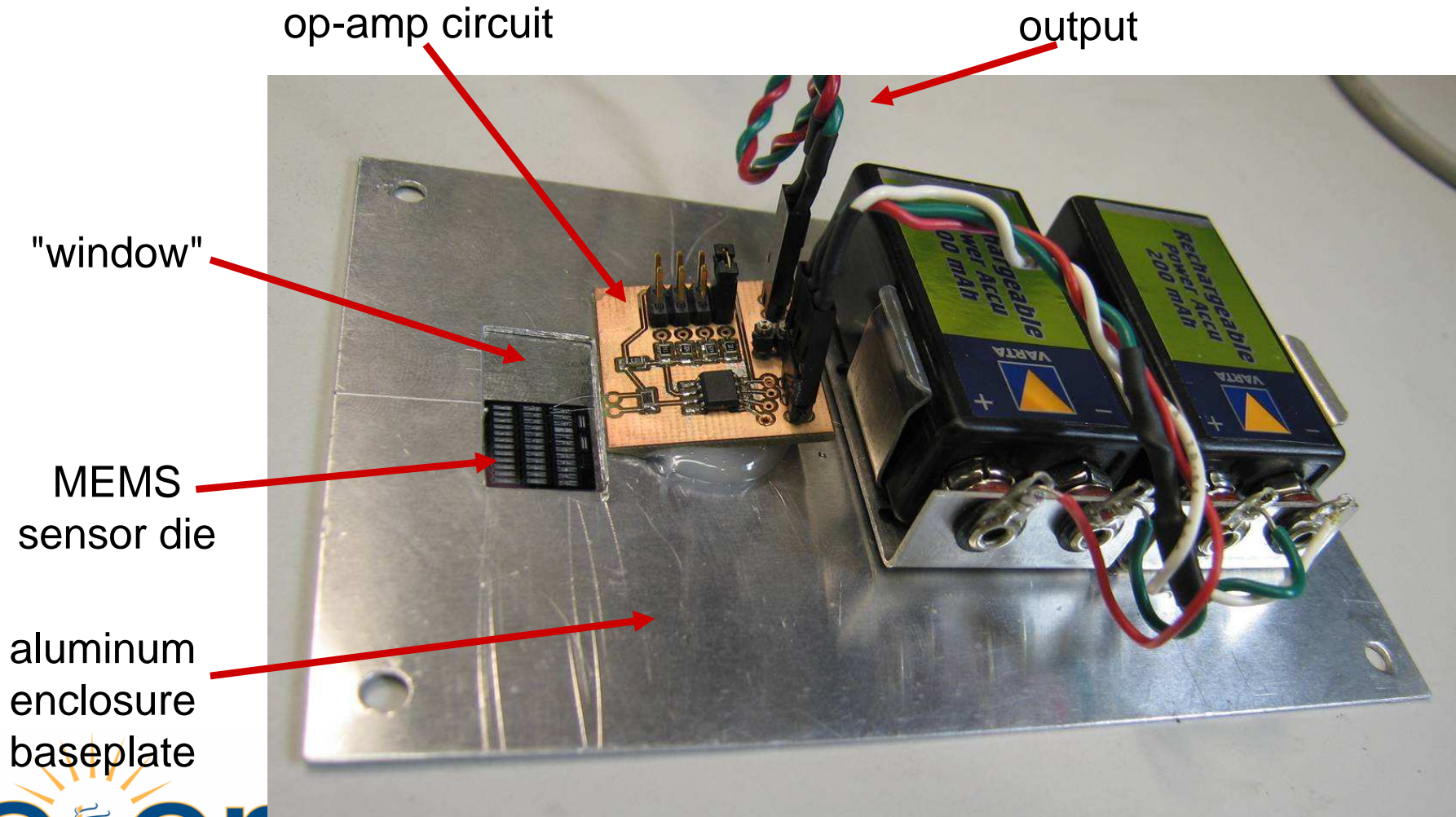
# AIN cantilevers are sensitive

- Assembled in shielded enclosure with 100x op-amp
- Actuated by lightly tapping enclosure exterior with the end of a wire
- ~800 mV pk-pk
- Resonance frequency ~3.7 kHz (no magnet) on a 1000 x 150 um cantilever
- No noticeable noise when waving a zip-cord carrying 13 A nearby

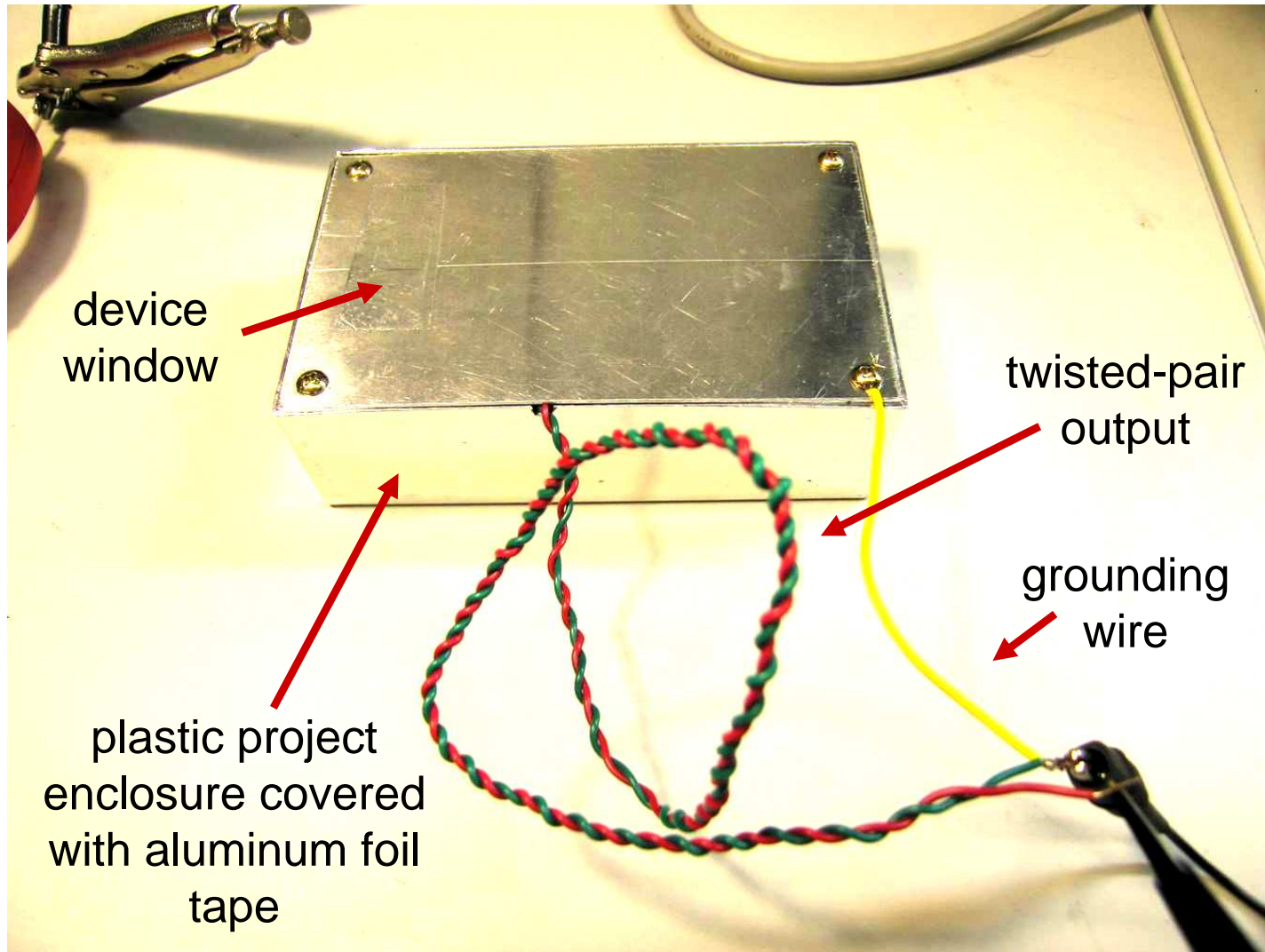




# Once the magnets are in place, put it all together



# Enclosure





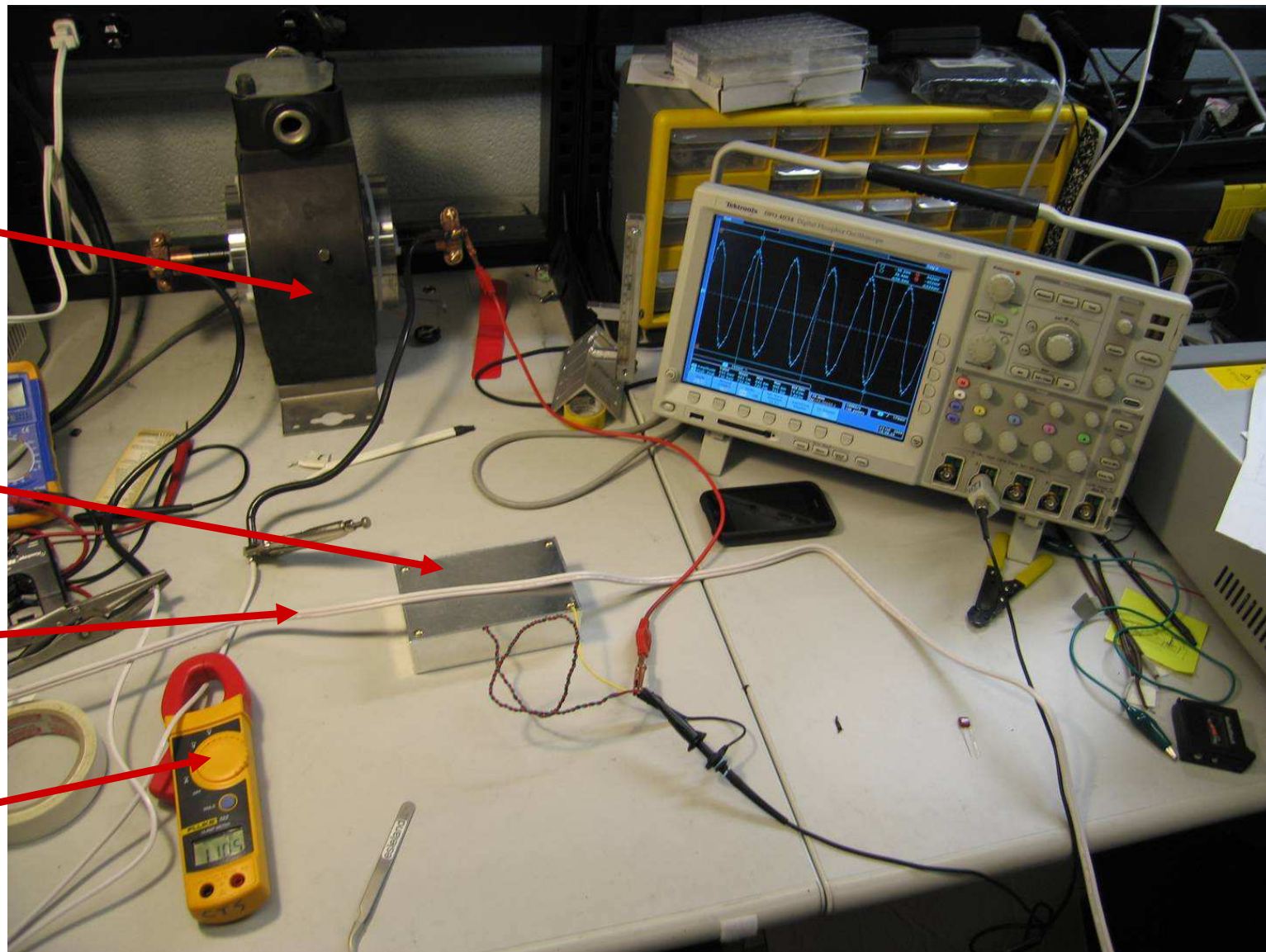
# Put it all together and test

current  
transformer  
signal generator

sensor  
enclosure

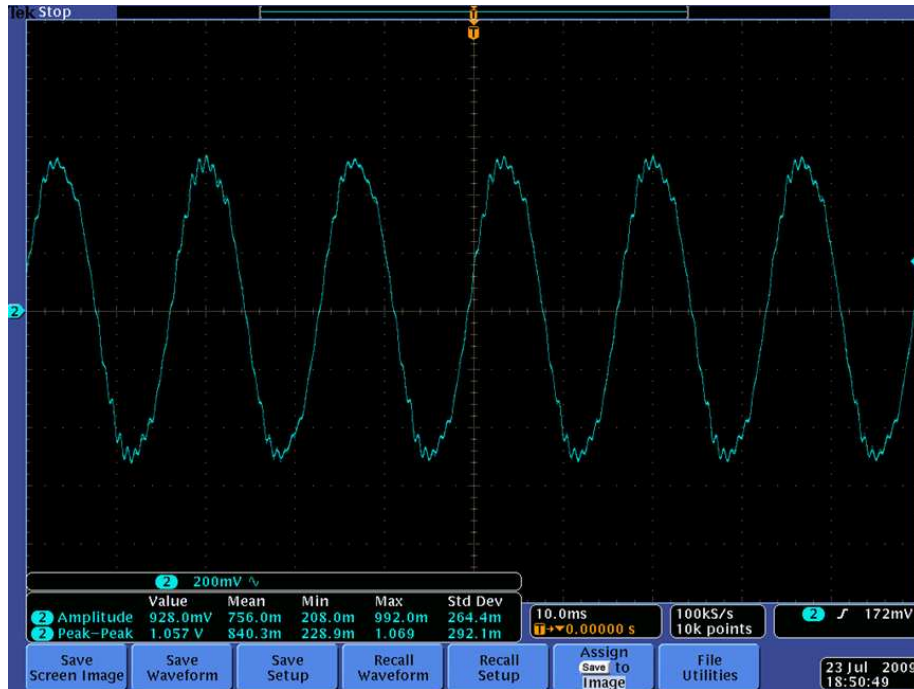
zip-cord

clamp meter  
for calibration



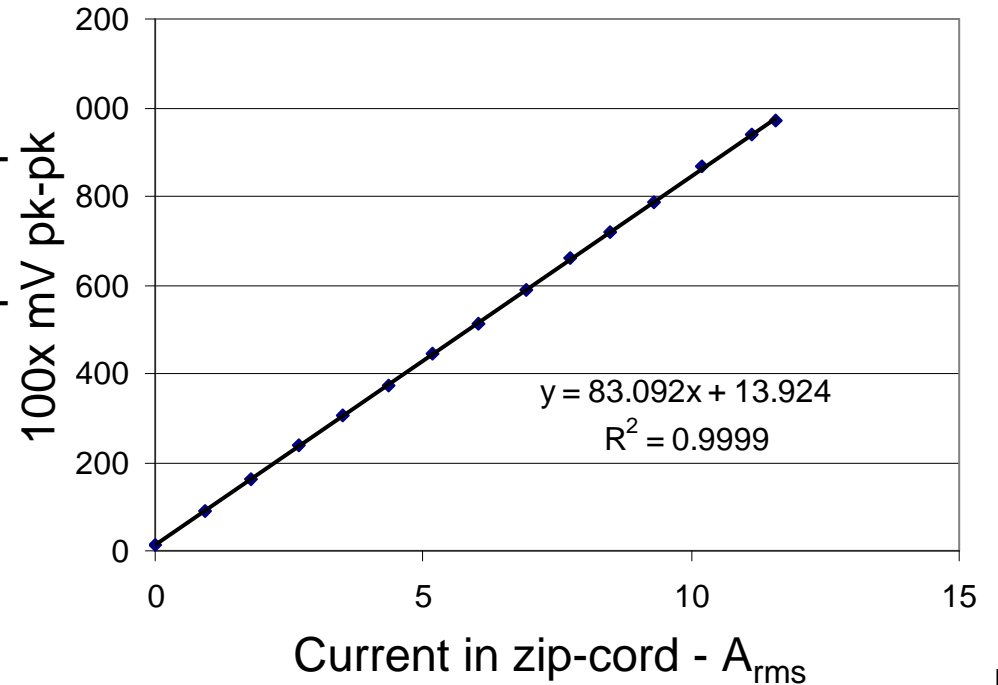


# And...it works



Sensor output amplified  
100x mV pk-pk

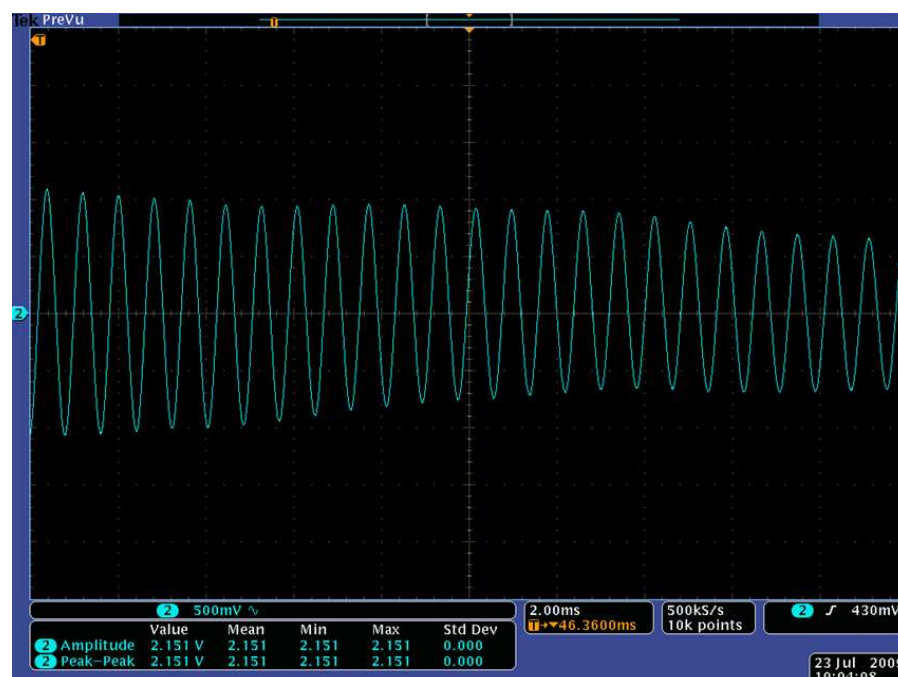
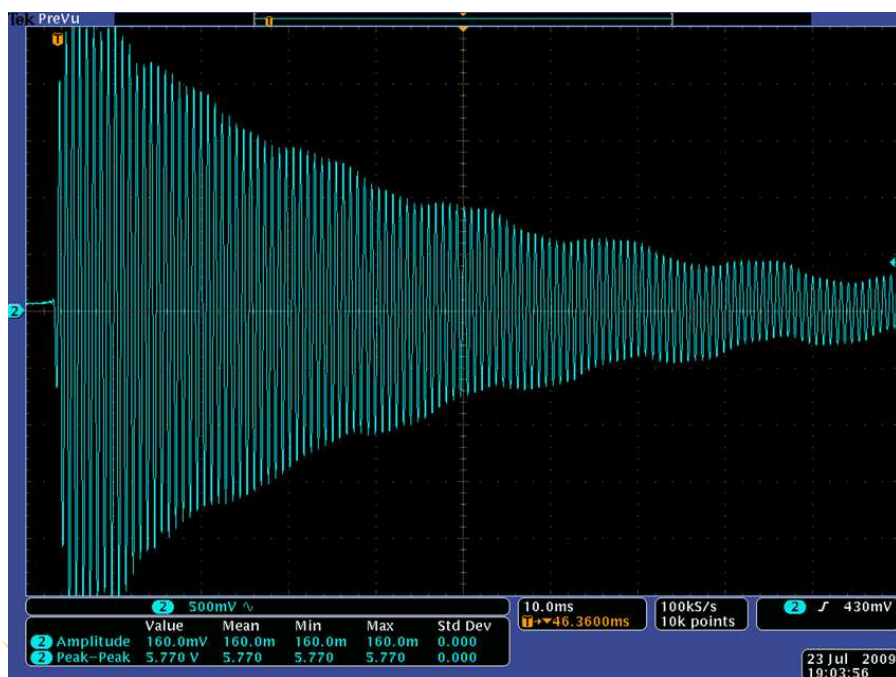
First system test - MEMS current sensor



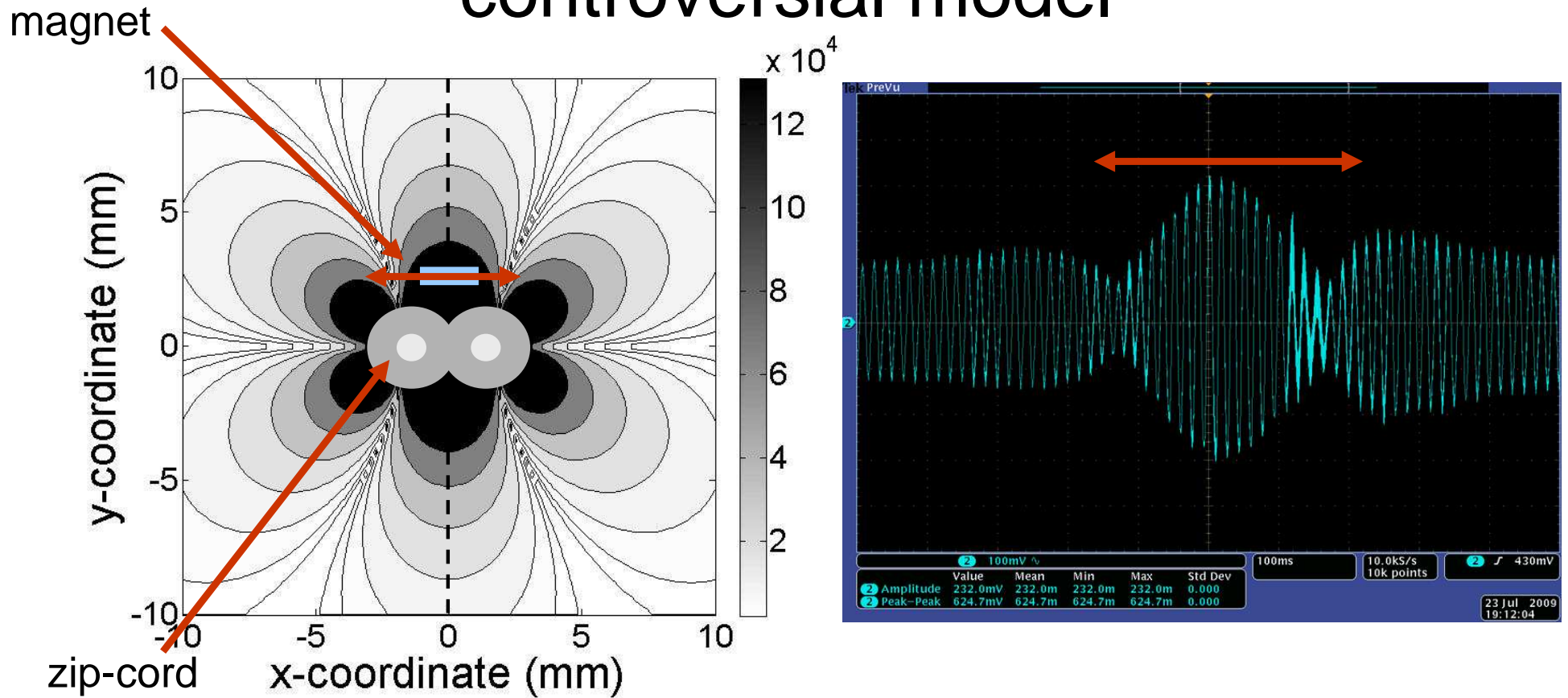
- Sensor response is highly linear measuring currents up to 11 A in a two-wire "zip-cord"
- Higher-order harmonics are also captured up to the device's resonance frequency (~1.2 kHz), research on transient response continues

# Device characterization

- With the magnet in place resonance frequency of a 1000 x 200 um cantilever is 1.22 kHz

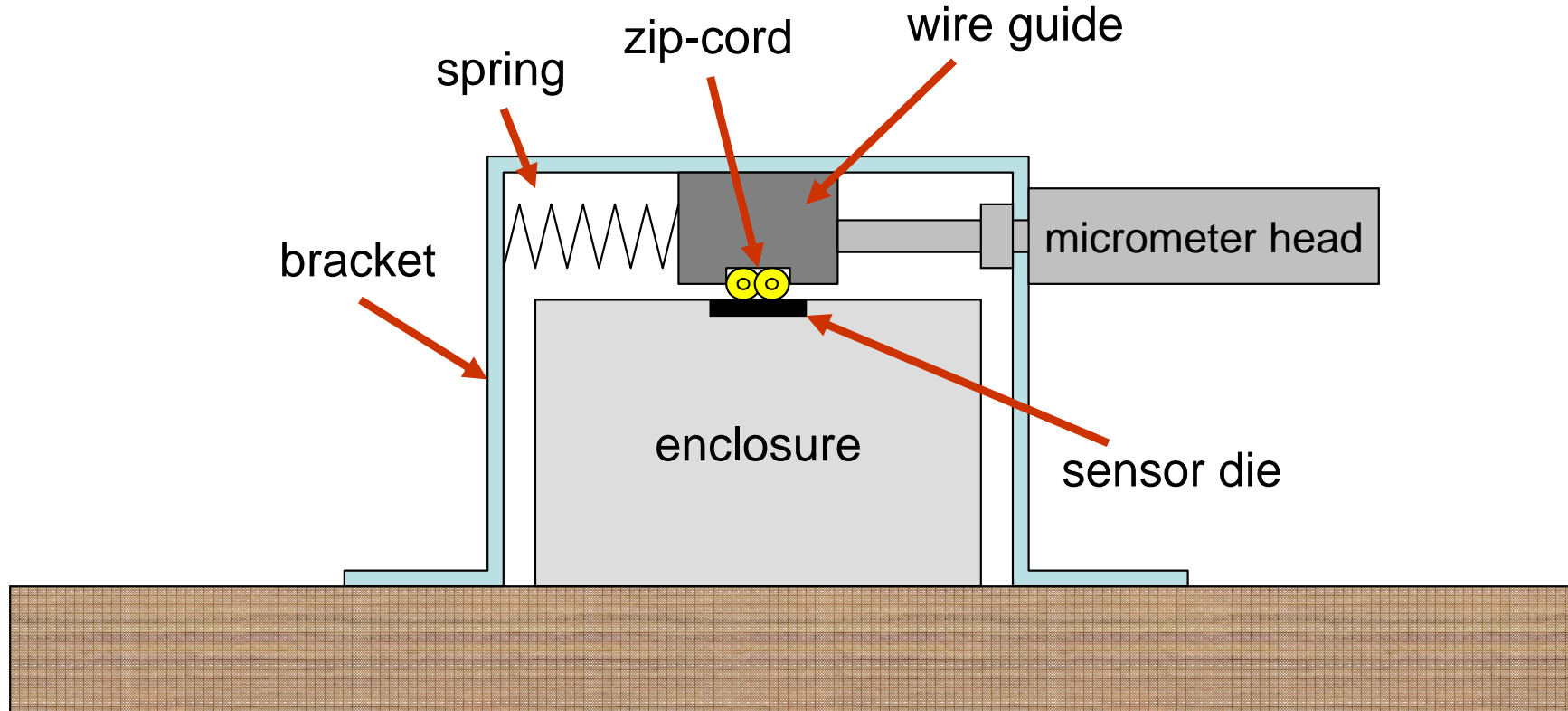


# Confirmation of a (somewhat) controversial model



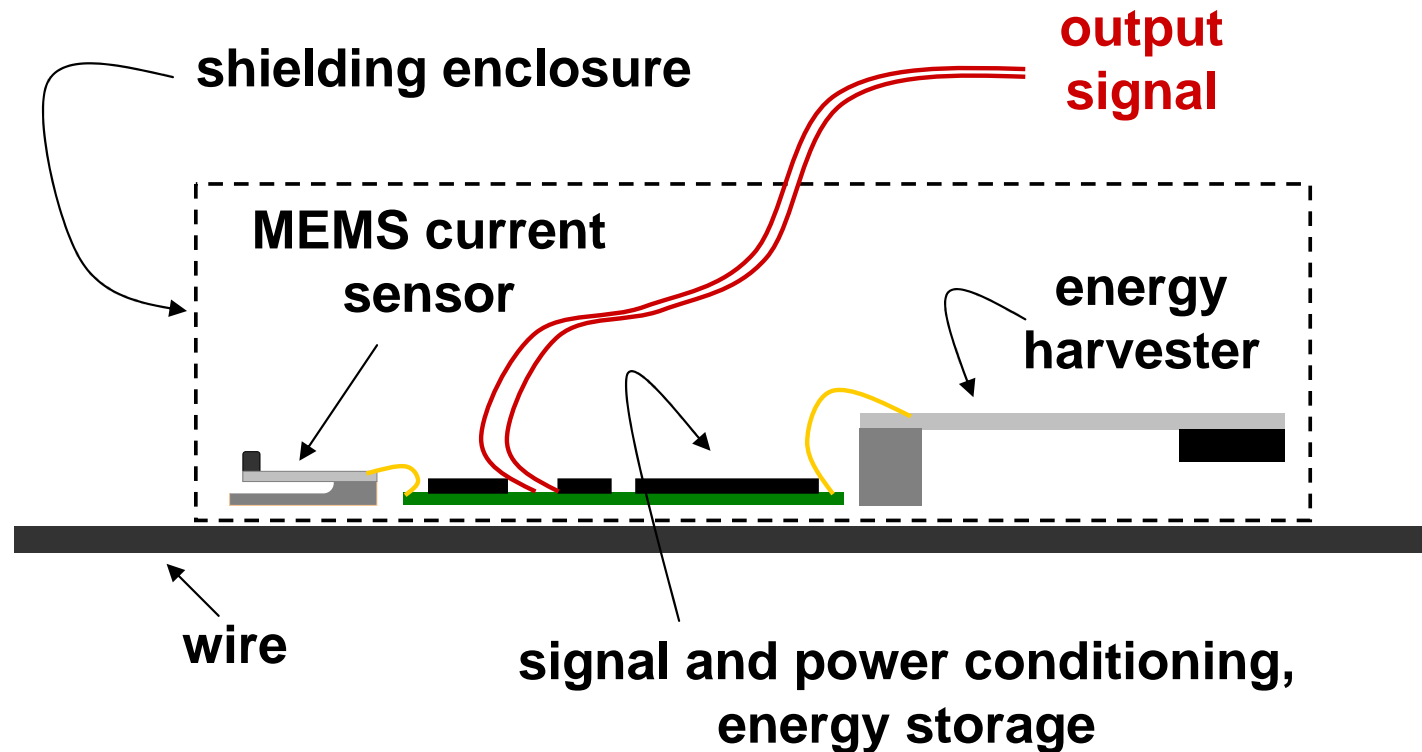
- By scanning the zip-cord over the sensor window, "force-field" plot is verified

# Test apparatus schematic



- This apparatus will allow detailed testing and characterization of multiple sensor and wire configurations
- As sensor is not visible from outside enclosure, micrometer allows for optimal positioning of wire relative to sensor

# Self-powered sensor demo

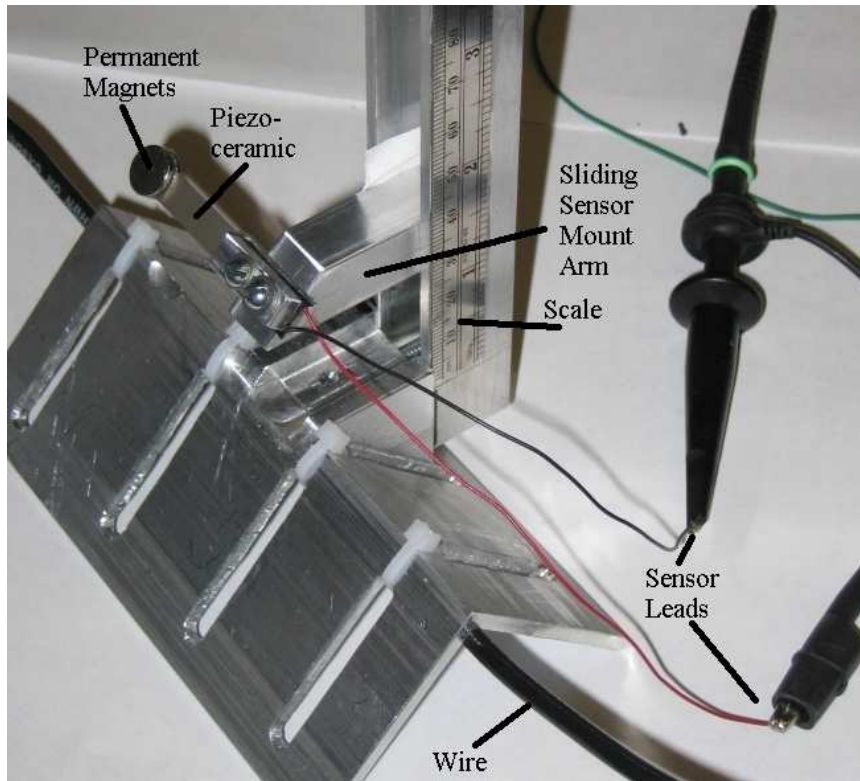


- Combine MEMS sensor with energy harvester and power conditioning and storage to demonstrate self-contained, self-powered sensor package
- All components have been fabricated, assembly and testing are underway

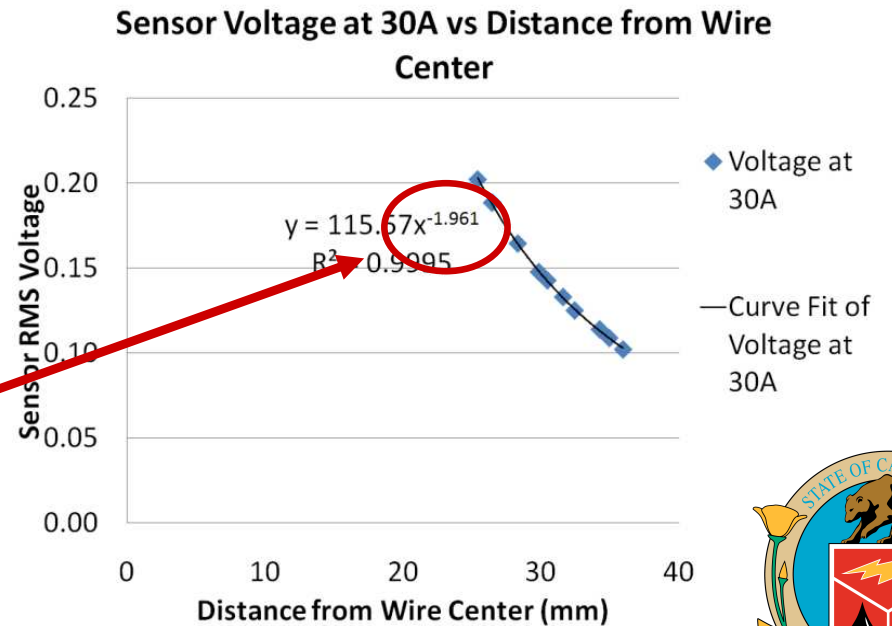
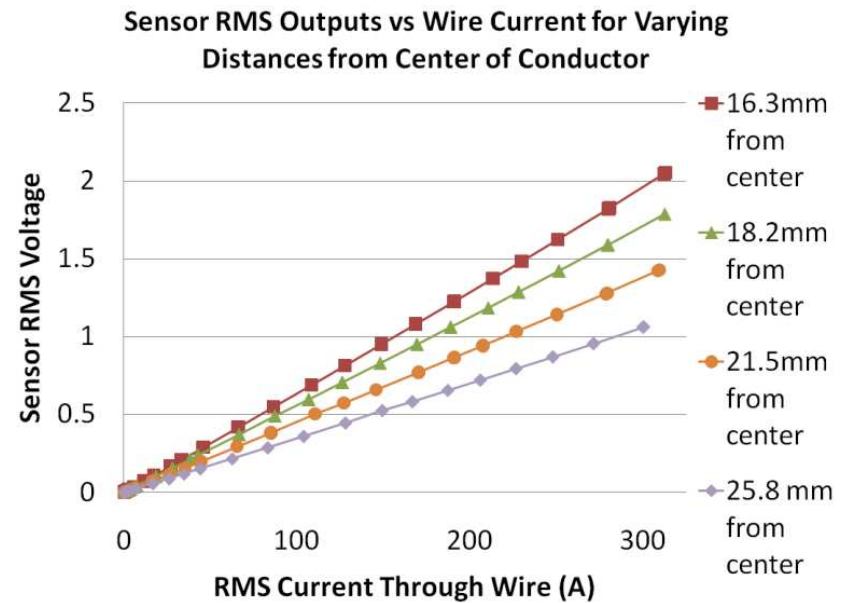


# Other continuing sensors research

# Analytical model confirmation at the meso-scale

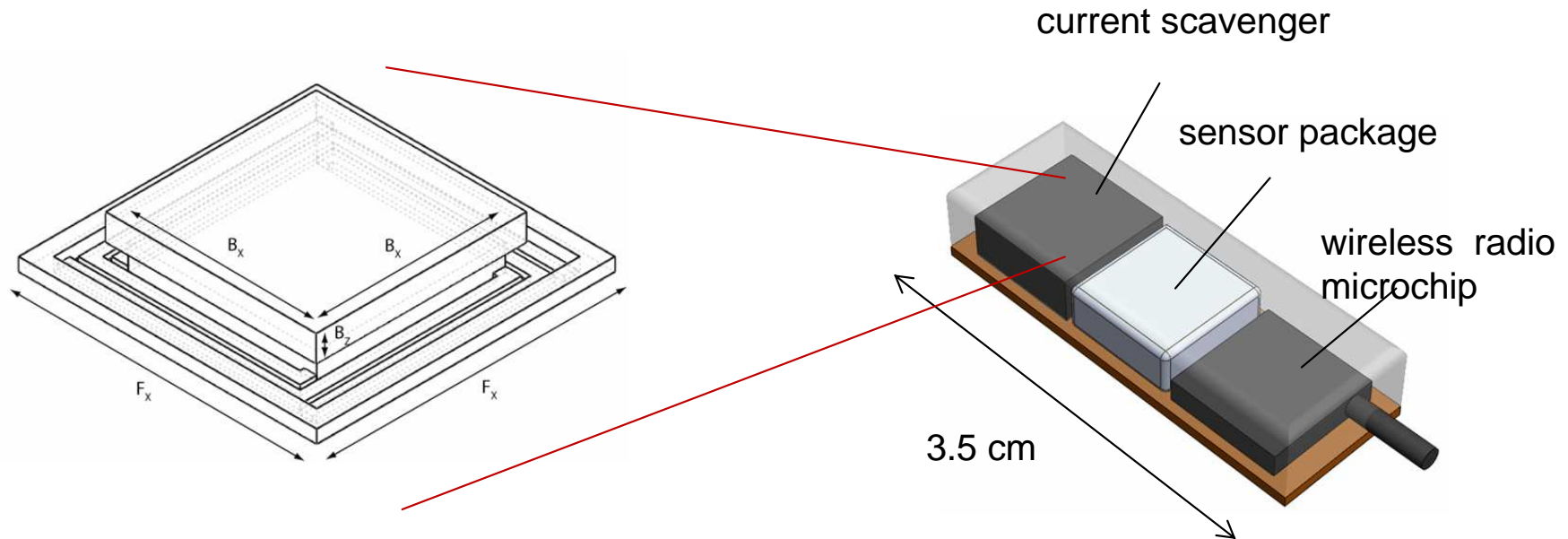


As sensor moves further from conductor, model predicts an inverse-square relationship, experimental result is  $x^{-1.96}$





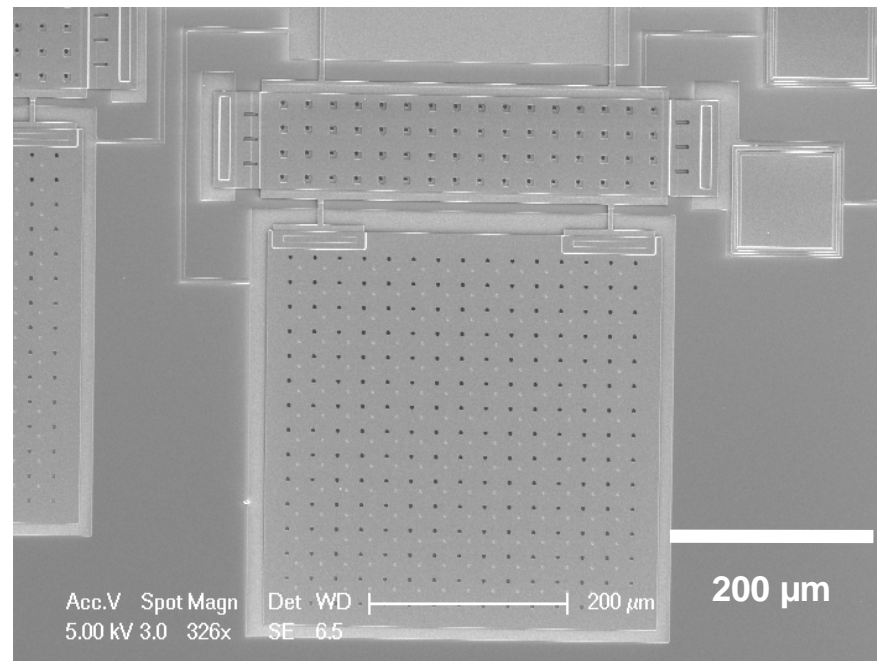
# In development: Optimized die-sized current scavenger for wireless sensor nodes



- In development: Optimizing a die sized (10x10x4 mm) current scavenger (to be presented at *PowerMEMS 2009, Washington D.C.*)
- Combining MEMS and macro-scale fabrication to optimize the efficiency of the scavenger given form-factor constraints

# Voltage and power sensing

- Prof. White and Dr. Igor Paprotny have fabricated an integrated MEMS power sensor and are working on MEMS voltage sensors. Research continues on these devices



**SEM of a fabricated MEMS passive proximity power sensor (testing ongoing)**

Thanks!

Questions?